

ATTY. DOCKET  
NO.  
37829.0800/  
Micron 01-0357

SERIAL NO.  
10/073,611

**INFORMATION DISCLOSURE  
CITATION**

(Use several sheets if necessary)

**APPLICANTS**

Paul A. LaBerge

**FILING DATE**  
February 11, 2002

**GROUP ART UNIT**  
TBA



**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE IF APPROPRIATE
DMB		6,069,506	5/30/00	Miller, Jr., et al.			
DMB		6,166,942	12/26/00	Vo, et al.			
DMB		6,240,003	5/29/01	McElroy			
DMB		6,225,165	5/1/01	Noble, Jr., et al.			
DMB		6,190,950	2/20/01	Noble			
DMB		6,215,145	4/10/01	Noble			

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**MAR 27 2002**

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**FOREIGN PATENT DOCUMENTS**

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB- CLASS	TRANSLATION

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**


**EXAMINER**

*Dennis M. Butler*

**DATE CONSIDERED**

*12/2/04*

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